

<b>Notice of References Cited</b>	Application/Control No. 11/951,501		Applicant(s)/Patent Under Reexamination DELVAUX ET AL.	
	Examiner Nicholas Polito		Art Unit 3673	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,223,369	05-2001	Maier et al.	5/713
*	C	US-2004/0074008	04-2004	Martens et al.	005/740
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	K	US-			
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	M	US-			

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**NON-PATENT DOCUMENTS**

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